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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Hiroshi Takeda et al.

§ Art Unit: 3683

Serial No.: 10/665,325

§ Examiner: Bradley T. King

Filed: September 18, 2003

§ Atty Docket: OMC.0003D1US
1241-US

For: Simplified Loading Device

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed October 19, 2004, please amend the above-referenced patent application as follows:

Date of Deposit: December 13, 2004
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden